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501.36931CX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: IWASAKI, et al  
Serial No.: 09/985,904  
Filed: November 6, 2001  
For: SEMICONDUCTOR DEVICE HAVNG LAYERED  
INTERCONNECT STRUCTRE WITH A COPPER OR PLATINUM  
CONDUCTING FILM AND A NEIGHBORING FILM (As Amended)  
Group: 2813  
Examiner: Stephen W. Smoot

**PETITION FOR EXTENSION OF TIME**

Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 11, 2003

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JUN 13 2003  
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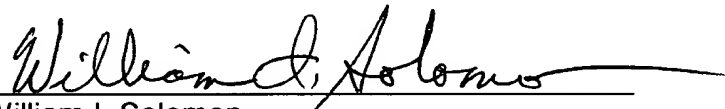
Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within the first month subsequent to expiration of the shortened statutory period set in the outstanding Office Action dated February 11, 2003. (A Credit Card Authorization form in the amount of \$110.00 is attached to cover the required fee)

It is requested that any shortage of fees due in connection with the filing of this paper, including extension of time fees, be charged to Deposit Account No. 01-2135 (reference 501.36931CX1), and please credit any excess fees to such deposit account.

Respectfully submitted,

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